Docket No.

0057-2533-2YY CONT

JUL 3 1 2003

PATENTAND TRADEMARK OFFICE IN THE UNITED STAT

IN RE APPLICATION OF:

Hideki TAKAHASHI

SERIAL NO:

09/421,217

GAU:

2811

RCE FILED:

March 6, 2003

EXAMINER: LOKE, STEVEN HO YIN

FOR:

INSULATED GATE SEMICONDUCTOR DEVICE WITH LOW ON VOLTAGE AND MANUFACTURING

METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Applicant(s) wish to disclose the following information.

REFERENCES

- ☐ The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of claims and drawings of the pending application is attached.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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LIST OF RELATED CASES

Docket Number	Serial or Patent Number	Filing or Issue Date	Inventor/ Applicant
0057-2533-2YY CONT*	09/421,217	10/20/99	TAKAHASHI
233930US2RE	10/426,700	05/01/03	TAKAHASHI

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